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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

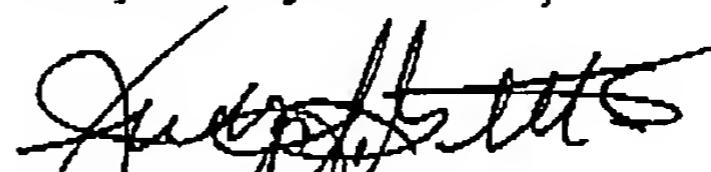
Applicant: Chen, et al. Docket No.: TSM6283131RI
Serial No: 10/650,886 Art Unit: 1763
Date Filed: August 28, 2003
Title: In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Request For Status Of Reissue Application (1 page)

Respectfully submitted,



Judy A. Betts
Legal Assistant

Confirmation Respectfully Requested

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: **Chen, et al.** Docket No: **TSM6283131RI**
Filed: **8/28/2003** Art Unit: **1763**
Serial No.: **10/650,886** Examiner: **George A. Goudreau**
For: **In-Situ Strip Process for Polysilicon Etching in Deep Sub-Micron Technology**

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR STATUS OF REISSUE APPLICATION

Dear Sir:

The PAIR website indicates that the Issue Revision was completed on July 5, 2005 for this reissue application. Applicants have received no further correspondence from the USPTO regarding the final examination of this reissue application.

Applicants respectfully request confirmation of the status of the final examination of this application and prompt issuance of the reissued patent.

September 14, 2005



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